



AT 10/20

TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i>		Application Number	10/020,961
		Filing Date	December 19, 2001
		First Named Inventor	Shunpei YAMAZAKI et al.
		Group Art Unit	2812
		Examiner Name	Stanetta Isaac
Total Number of Pages in This Submission		Attorney Docket Number	740756-2410

ENCLOSURES (check all that apply)		
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	Jeffrey L. Costellia - Reg. No. 35,483 Nixon Peabody LLP 401 9 th Street, N.W. Suite 900 Washington, D.C. 20004-2126
Signature	
Date	September 16, 2005

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Docket No. 740756-2410

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Shunpei YAMAZAKI et al.) Group Art Unit: 2812
Serial No. 10/020,961) Examiner: Stanetta Isaac
Filed: December 19, 2001) Confirmation No. 7583
For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEIVE) Date: September 16, 2005

REQUEST FOR RECONSIDERATION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 16, 2005, Applicants respond as follows.

REMARKS

The Office Action of June 16, 2005 was received and carefully reviewed. Reconsideration and withdrawal of the currently pending rejections are requested for the reasons advanced in detail below.

Claims 6-22 and 28-44 continue to be rejected under 35 U.S.C. 103(a) as being unpatentable over Makita et al. (U.S. Patent No. 5,821,562) in view of Henley et al. (U.S. Patent No. 6,683,324). Applicants contend that this rejection is not proper for the reasons advanced in the Amendment of April 1, 2005. Further, Applicants further contend that the Examiner fails to provide a motivation for combining the teachings of Makita with that of Henley. As a result, it is respectfully requested that the Examiner provide a more specific explanation of where there is a suggestion in the references to combine their teachings.

Applicants believe that there is actually no motivation or suggestion to combine or modify Makita in view of Henley. Makita teaches forming an impurity region in a crystalline region in a crystalline semiconductor film, while Henley teaches forming a gettering layer containing a noble gas over a crystalline silicon film. Applicants contend that none of the